



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor Weimin Li et al
Assignee Micron Technology, Inc.
Group Art Unit 2818
Examiner D. Vu
Attorney's Docket No. MI22-1035
Title: Semiconductor Processing Methods

PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Box RCE
Art Unit 2818
Assistant Commissioner for Patents
Washington, D.C. 20231

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 West First Avenue, Suite 1300
Spokane, WA 99201-3828

*24/Pm-
Response
C. Stanley
7-23-02*

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REMARKS

This Request for Continued Examination (RCE) Application is being filed in an abundance of caution to permit consideration of a Supplemental Information Disclosure Statement.

Applicants take strong exception to the Office's Statement on Reasons for Allowance. The Office is reminded that the patent statutes require claims to be presented and interpreted in accordance with what the Applicants regard as their invention, not as to what the Office regards as the invention. Accordingly, the Office must read the claims as Applicants regard them (as they are worded), not as the Office might regard them.

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